

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Kazutoshi OHMORI et al.

Appln. No.:

Filed: HERewith

For: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

\* \* \*

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any assertion as to materiality or prior art effect, the documents listed on the attached Form PTO-1449 are hereby cited.

Documents AH-AP and BH-BJ on the attached List were cited in the specification, on pages 2-4, and their relevance is indicated therein. Documents AA-AG are U.S. counterparts to Documents AH, AI, AL, AO, AP, BH, and BL, respectively.

Respectfully submitted,

MWS:sjk

Miles & Stockbridge P.C.  
1751 Pinnacle Drive  
Suite 500  
McLean, Virginia 22102-3833  
(703) 903-9000  
October 15, 2003

By: 

Mitchell W. Shapiro  
Reg. No. 31,568

<b>FORM PTO-1449</b>		<b>Atty. Docket No.</b> XA-9959	<b>Appln. No.</b>
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b>			
		<b>Applicant</b> Kazutohi OHMORI et al.	
		<b>Filing Date</b> HEREWITH	<b>Group</b>

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA	6,479,408	11/12/02	Shioya et al.	438	789	
	AB	6,340,435	01/22/02	Bjorkman et al.	216	72	
	AC	2002/0168849	11/14/02	Lee et al.	438	637	
	AD	6,255,217	07/03/01	Agnello et al.	438	687	
	AE	2001/0054765	12/27/01	Ohito et al.	257	751	
	AF	2002/0192945	12/19/02	Nagahara	438	637	
	AG	2003/0030146	02/13/03	Tamaru et al.	257	762	

**FOREIGN PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AH	2001-326279	11/22/01	Japan			Abstract
	AI	2001-110789	04/20/01	Japan			Yes
	AJ	2002-203899	07/19/02	Japan			Abstract
	AK	2002-134494	05/10/02	Japan			Abstract
	AL	2002-353310	12/06/02	Japan			Abstract
	AM	2003-142593	05/16/03	Japan			Abstract
	AN	2003-152076	05/23/03	Japan			Abstract
	AO	2000-200832	07/18/00	Japan			Abstract
	AP	2002-9150	01/11/02	Japan			Abstract

**OTHER** (including author, title, date, pertinent pages, etc.)

	AQ	
	AR	
	AS	
<b>Examiner</b>		<b>Date Considered</b>
<b>EXAMINER:</b> Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.		

FORM PTO-1449

Atty. Docket No.

Appln. No.

XA-9959

**LIST OF DOCUMENTS CITED BY APPLICANT**

Applicant

Kazutohi OHMORI et al.

Filing Date

HEREWITH

Group

**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Sub-class	Filing Date
	BA					
	BB					
	BC					
	BD					
	BE					
	BF					
	BG					

**FOREIGN PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Country	Class	Sub-class	Translation
	BH 2002-373936	12/26/02	Japan			Abstract
	BI 2002-170882	06/14/02	Japan			Abstract
	BJ 2002-270691	09/20/02	Japan			Abstract
	BK 2002-324837	11/08/02	Japan			Abstract
	BL 2003-60030	02/28/03	Japan			Abstract
	BM					
	BN					
	BO					
	BP					

**OTHER** (including author, title, date, pertinent pages, etc.)

	BQ	
	BR	
	BS	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.